

***Interactive comment on “Assessment of nocturnal
Aerosol Optical Depth from lunar photometry at
Izaña high mountain Observatory” by
África Barreto et al.***

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The authors want to highlight, regarding the Comment #2, that the two measurements at 1020 nm performed with the silicon and the InGaAs detectors are used as quality control to assess the stability of measurements performed with both detectors. However, only 1020 nm silicon measurements are commonly used to derive AOD.

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